



1762
JPW

Attorney Docket SEL 238

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of)
)
Hiroki et al.)
)
Serial No.: 09/776,472)
)
Filed: February 2, 2001)
)
For: Thin Film Formation Apparatus And)
Method Of Manufacturing Self-Light-)
Emitting Device Using Thin Film)
Formation Apparatus)
)
Art Unit: 1762)
)
Examiner: M. Cleveland)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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Shannon Wallace
Name of applicant, assignee, or Registered Rep.
Shannon Wallace 3/8/05
Signature Date

RESPONSE F TO OFFICE ACTION

Sir:

Applicants have the following response to the Office Action of December 8, 2004.

Applicants will address each of the Examiner's objections and rejections in the order in which they appear in the Office Action.